



IFW

Attorney Docket no: 0553-0200.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yamazaki et al.

Serial No.: 10/664,615

Filed: September 19, 2003

For: Semiconductor Device And Manufacturing
Method Thereof

Examiner: Khiem D. Nguyen

Art Unit: 2823

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Commissioner for Patents
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Alexandria, VA 22313-1450

AMENDMENT B

In response to the Office Action dated June 8, 2004, a three month extension of time being submitted herewith, please amend the above-identified application as follows: